

FORM PTO-1449  INFORMATION DISCLOSURE CITATION IN AN APPLICATION								Docket Number (Optional) 100-22400 (P05620)	Application No. NEW 10/625,010			
Express Mail Number <u>EV342470388US</u> (Use several sheets if necessary)								Applicant(s) Kevin Weaver et al.				
								Filing Date Herewith	Group Art Unit Unknown 2818			
U.S. PATENT DOCUMENTS												
EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TH	6	2	1	1	5	2	7	04/03/01	Chandler	250	492.2	02/11/99
TH	6	4	9	2	2	6	1	12/10/02	Gavish et al.	438	637	12/30/00
FOREIGN PATENT DOCUMENTS												
	DOCUMENT NUMBER				DATE	COUNTRY		CLASS	SUBCLASS	Translation		
										Yes	No	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)												
TH	Caiwen Yuan et al., "Application of Focused Ion Beam in Debug and Characterization of 0.13µm Copper Interconnect Technology", Proceedings from the 28 <sup>th</sup> International Symposium for Testing and Failure Analysis, November 3-7, 2002, Phoenix, Arizona, pp. 183-188.											
EXAMINER	TU-TIe HO	DATE CONSIDERED								Feb, 2005		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.												